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JWD 6/11/07

RESPONSE UNDER 37 C.F.R.  
§1.116 EXPEDITED PROCEDURE  
EXAMINING GROUP 1723

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicants:** Mark S. Chace et al.

**Examiner:** Joseph W. Dodge

**Serial No.:** 10/695,374

**Art Unit:** 1723

**Filed:** October 28, 2003

**Docket:** FIS920030172US1 (16645)

**For:** PROCESS FOR REMOVING  
IMPURITIES FROM LOW DIELECTRIC  
CONSTANT FILMS DISPOSED ON  
SEMICONDUCTOR DEVICES

**Dated:** May 31, 2007

**Confirmation No.:** 5323

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.116

Sir:

In response to the Official Action dated April 24, 2007, please amend the above-identified application as follows:

**Amendment to the claims** begin at Page 2 of this paper.

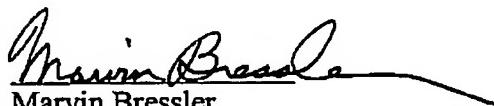
**Remarks/Arguments** begin at Page 8 of this paper.

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CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website, on May 31, 2007.

**Dated:** May 31, 2007

  
Marvin Bressler